

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor D. V. Nirmal Ramaswamy et al.
Assignee Micron Technology, Inc.
Group Art Unit 1722
Examiner Robert M. Kunemund
Attorney's Docket No. MI22-2520
Title: Methods of Depositing an Elemental Silicon-Comprising material Over a Substrate

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References –See Attached Form PTO/SB/08a

The attached form PTO/SB/08a is submitted in compliance with 37 CFR §1.56. No copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: March 27, 2007

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